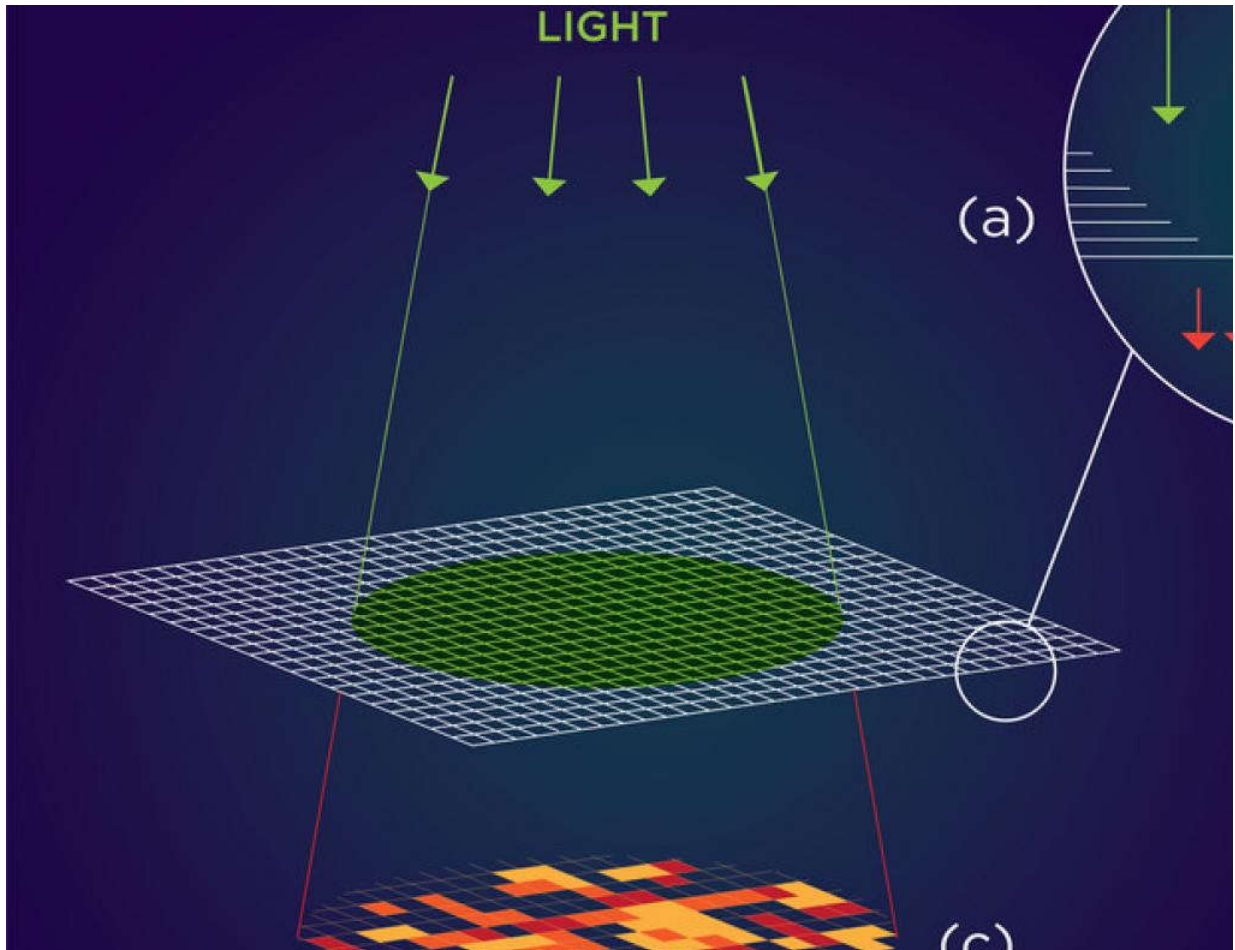


## PRESS RELEASE

## The Ultimate Defense Against Hackers May Be Just a Few Atoms Thick

November 29, 2017

NYU Tandon Researchers Discover Big Cryptographic Potential in Nanomaterial



(a) At monolayer thickness, this material has the optical properties of a semiconductor that emits light. At multilayer, the properties change and the material doesn't emit light. (b) Multilayer thickness: The material is speckled with randomly occurring regions that alternately emit or block light. (c) Upon exposure to light, this pattern can be translated into a one-of-a-kind authentication pattern.

BROOKLYN,

New

York

-

The

next

generation

of

electronic

hardware

security

may

be

hand  
as  
researchers  
at  
New  
York  
University  
Tandon  
School  
of  
Engineering  
introduce  
a  
new  
class  
of  
unclonable  
cybersecurity  
security  
primitives  
made  
of  
a  
low-  
cost  
nanomaterial  
with  
the  
highest  
possible  
level  
of  
structural  
randomness.  
Randomness  
is  
highly  
desirable  
for  
constructing  
the  
security  
primitives  
that  
encrypt  
and  
thereby  
secure  
computer

and  
data  
physically,  
rather  
than  
by  
programming.

In  
a  
paper  
published  
in  
the  
journal  
ACS  
Nano,  
Assistant  
Professor  
of  
Electrical  
and  
Computer  
Engineering

[Davood  
Shahrjerdi](#)

and  
his  
NYU  
Tandon  
team  
offer  
the  
first  
proof  
of  
complete  
spatial  
randomness  
in  
atomically  
thin  
molybdenum  
disulfide  
(MoS<sub>2</sub>).  
The  
researchers  
grew  
the  
nanomaterial

layers,  
each  
roughly  
one  
million  
times  
thinner  
than  
a  
human  
hair.  
By  
varying  
the  
thickness  
of  
each  
layer,  
Shahrjerdi  
explained,  
they  
tuned  
the  
size  
and  
type  
of  
energy  
band  
structure,  
which  
in  
turn  
affects  
the  
properties  
of  
the  
material.

“At  
monolayer  
thickness,  
this  
material  
has  
the  
optical  
properties  
of

semiconductor  
that  
emits  
light,  
but  
at  
multilayer,  
the  
properties  
change,  
and  
the  
material  
no  
longer  
emits  
light.  
This  
property  
is  
unique  
to  
this  
material,”  
he  
said.  
By  
tuning  
the  
material  
growth  
process,  
the  
resulting  
thin  
film  
is  
speckled  
with  
randomly  
occurring  
regions  
that  
alternately  
emit  
or  
do  
not  
emit  
“...+

When  
exposed  
to  
light,  
this  
pattern  
translates  
into  
a  
one-  
of-  
a-  
kind  
authentication  
key  
that  
could  
secure  
hardware  
components  
at  
minimal  
cost.

Shahrjerdi  
said  
his  
team  
was  
pondering  
potential  
applications  
for  
what  
he  
described  
as  
the  
beautiful  
random  
light  
patterns  
of  
MoS2  
when  
he  
realized  
it  
would  
be

valuable  
as  
a  
cryptographic  
primitive.  
This  
represents  
the  
first  
physically  
unclonable  
security  
primitive  
created  
using  
this  
nanomaterial.  
Typically  
embedded  
in  
integrated  
circuits,  
physically  
unclonable  
security  
primitives  
protect  
or  
authenticate  
hardware  
or  
digital  
information.  
They  
interact  
with  
a  
stimulus  
—  
in  
this  
case,  
light  
—  
to  
produce  
a  
unique  
response  
\*\*\*

can  
serve  
as  
a  
cryptographic  
key  
or  
means  
of  
authentication.

The  
research  
team  
envisions  
a  
future  
in  
which  
similar  
nanomaterial-  
based  
security  
primitives  
can  
be  
inexpensively  
produced  
at  
scale  
and  
applied  
to  
a  
chip  
or  
other  
hardware  
component,  
much  
like  
a  
postage  
stamp  
to  
a  
letter.  
“No  
metal  
contacts



required,  
and  
production  
could  
take  
place  
independently  
of  
the  
chip  
fabrication  
process,”  
Shahrjerdi  
said.  
“It’s  
maximum  
security  
with  
minimal  
investment.”

The  
paper,  
“Physically  
Unclonable  
Cryptographic  
Primitives  
by  
Chemical  
Vapor  
Deposition  
of  
Layered  
MoS<sub>2</sub>”  
appears  
in  
the  
journal  
*ACS  
Nano*  
at

<http://pubs.acs.org/doi/10.1021/acsnano.7b07568>.

Co-  
authors  
include  
NYU  
Tandon  
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candidate  
**Abdullah**

and  
graduate  
students  
**Darren  
Armstrong**  
and  
**Somayah  
Alharbi.**  
The  
National  
Science  
Foundation  
and  
the  
U.S.  
Army  
Research  
Office  
supported  
the  
research.

**About  
the  
New  
York  
University  
Tandon  
School  
of  
Engineering**  
*The  
NYU  
Tandon  
School  
of  
Engineering  
dates  
to  
1854,  
the  
founding  
date  
for  
both  
the  
New  
York  
University  
School*

*Civil  
Engineering  
and  
Architecture  
and  
the  
Brooklyn  
Collegiate  
and  
Polytechnic  
Institute  
(widely  
known  
as  
Brooklyn  
Poly).  
A  
January  
2014  
merger  
created  
a  
comprehensive  
school  
of  
education  
and  
research  
in  
engineering  
and  
applied  
sciences,  
rooted  
in  
a  
tradition  
of  
invention  
and  
entrepreneurship  
and  
dedicated  
to  
furthering  
technology  
in  
service  
to  
...*

In  
addition  
to  
its  
main  
location  
in  
Brooklyn,  
NYU  
Tandon  
collaborates  
with  
other  
schools  
within  
NYU,  
the  
country's  
largest  
private  
research  
university,  
and  
is  
closely  
connected  
to  
engineering  
programs  
at  
NYU  
Abu  
Dhabi  
and  
NYU  
Shanghai.  
It  
operates  
Future  
Labs  
focused  
on  
start-  
up  
businesses  
in  
downtown  
Manhattan  
and  
Brooklyn.

and  
an  
award-  
winning  
online  
graduate  
program.  
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more  
information,  
visit  
[engineering.nyu.edu](http://engineering.nyu.edu).



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